



RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2851

00862.022151.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: H. Nguyen
Masaya OGURA et al.)	
	:	Group Art Unit: 2851
Application No.: 09/811,419)	
	:	Confirmation No.: 9530
Filed: March 20, 2001)	
	:	
For: EXPOSURE APPARATUS, METHOD OF)		April 29, 2004
MANUFACTURING SEMICONDUCTOR :		
DEVICES AND PLANT THEREFOR)		

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the final Official Action dated January 29, 2004, please amend the above-identified application as follows, pursuant to 37 C.F.R. § 1.116:

Do not
enter
5/7/04
HN